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MICHAEL BURNS

TRANSMITTAL LETTER TO THE U.S. DESIGNATED OFFICE (DO/US)--  
ENTRY INTO THE U.S. NATIONAL STAGE UNDER CHAPTER I

International Application Number	International Filing Date	International Earliest Priority Date
PCT/EP01/03983	06 April 2001	16 May 2000

Title: GATE ETCH PROCESS FOR 12 INCH WAFERS

Applicant: GREWAL, Virinder et al.

Box PCT  
Assistant Commissioner for Patents  
Washington D.C. 20231  
ATTENTION: DO/US

Applicants herewith submit to the United States Designated Office (DO/US) the following items under 35 U.S.C. 371:

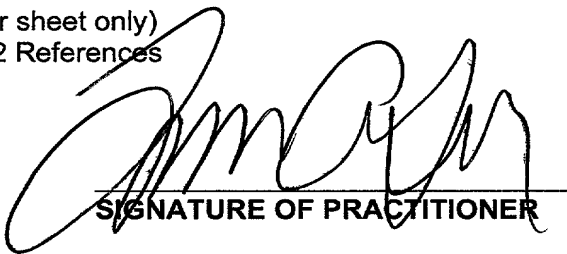
- A copy of the International application as filed (35 U.S.C.371(c)(2))
- Counsel's payment in the amount of \$890.00.

Other documents or information included:

- International Search Report
- PCT Request
- PCT Publication WO 01/88973 A1 (cover sheet only)
- Information Disclosure Statement and 12 References

Date: January 16, 2002

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SIGNATURE OF PRACTITIONER

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